



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/783,418
Filing Date February 19, 2004
Inventor Jianxing Li et al.
Assignee Honeywell International Inc.
Group Art Unit 2812
Examiner Gurley, Lynne Ann
Attorney's Docket No. 30-5082-DIV1
Title: Sputtering Target Compositions, and Methods of Inhibiting Copper
Diffusion into a Substrate

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached with the exception of U.S. patents and published U.S. applications (1276 Off. Gaz. Pat. Off. 55, 05 Aug 2003). No admission is made regarding whether all the submitted references are prior art. Citation of the referenced art is respectfully requested.

This Supplemental Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing date of a first Office Action on the merits, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated:

June 10, 2005

By:

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. 30-5082-DIV1		SERIAL NO. 10/783,418	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Jianxing Li et al.			
					FILING DATE February 19, 2004		GROUP 2812	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Sub- class	Filing Date If Appropriate	
	AA	3,592,639	07-1971	Schussler et al.				
	AB	6,323,055	11-2001	Rosenberg et al.				
	AC	6,312,779	11-2001	Hirotsune et al.				
	AD	5,781,256	07-1998	Inoue et al.				
	AE	5,170,244	12-1992	Dohjo et al.				
	AF	4,938,798	07-1990	Chiba et al.				
	AG	4,731,116	03-1988	Kny				
	AH	6,827,828	12-2004	Wang				
	AI	2004/0168932	09-2004	Wang				
	AJ	2002/0139667	10-2002	Wang				
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Clas s	Subc lass	Translation	
							Yes	No
	AK	JP01230767A	09-1989	Japan				
	AM	JP05171417A	07-1993	Japan				
	AN	JP2003055761A	02-2003	Japan				
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR	ASM Handbook, Vol. 3, Alloy Phase Diagrams, 1992, pg. 375						
	AS	Constitution of Binary Alloys, 1958, pg. 1226						
EXAMINER				DATE CONSIDERED				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								